## Notice of References Cited Application/Control No. | Applicant(s)/Patent Under Reexamination | IMAI, TAKASHI | Examiner | Art Unit | Page 1 of 1

## **U.S. PATENT DOCUMENTS**

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
*	Α	US-2002/0029090 A1	03-2002	Pierre Bertin et al.	700/94
*	В	US-2003/0172223 A1	09-2003	Ying et al.	710/316
*	O	US-2003/0236934 A1	12-2003	Park, Hee-Chun	710/74
*	D	US-5,784,581	07-1998	Hannah, Eric C.	710/110
*	E	US-6,636,923	10-2003	Meirsman et al.	710/305
	F	US-			
	G	US-			
	Н	US-			
	ı	US-			
	J	US-			
	К	US-			
	L	US-	•		
	М	US-			

## FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
	N					
	0					
	Р					
	Q					
	R					
	s			·		
	Т					

## **NON-PATENT DOCUMENTS**

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	υ	
	٧	
	w	
	×	

\*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).) Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.